

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Francisco ARIAS et al.

Examiner: Mathieu D. VARGOT

Serial No.: 10/727,124

Group Art Unit: 1732

Filing Date: December 3, 2003

Confirmation No: 4751

Title: METHOD OF MANUFACTURING MICRONEEDLE STRUCTURES USING SOFT LITHOGRAPHY AND PHOTOLITHOGRAPHY

RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is in response to the Notice of Non-Compliant Amendment mailed from the PTO on June 12, 2008.

The ***Listing of the Claims*** begins on page 2 of this document. The claims are not amended in the present paper.

Remarks begin on page 7 of this document.